

**Section I. (Amendments to the Specification)**

At page 1 of the application, please amend paragraph [0001] as set out below:

[0001] This is a continuation-in-part of U.S. Patent Application No. 10/273,036 filed October 17, 2002 and issued on July 25, 2006 as U.S. Patent No. 7,080,545 for “APPARATUS AND PROCESS FOR SENSING FLUORO SPECIES IN SEMICONDUCTOR PROCESSING SYSTEMS” in the names of Frank Dimeo Jr., Philip S.H. Chen, Jeffrey W. Neuner, James Welch, Michele Stawasz, Thomas H. Baum, Mackenzie E. King, Ing-Shin Chen, and Jeffrey F. Roeder.